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JUN 13 2006

PATENT
YOR919980056US1
IBM-304

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Marie Angelopoulos
Serial Number	:	09/256,034
Filing Date	:	February 23, 1999
Examiner	:	John S. V. Chu
Group Art Unit	:	1752
For	:	MULTILAYERED RESIST SYSTEMS...THEREOF

TO: The Honorable Commissioner of Patents
Post Office Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated March 13, 2006, please amend the above-identified application as follows:

IN THE CLAIMS

Amend the claims as set forth in the Appendix attached hereto.

REMARKS

Applicant reiterates that in the production of semi-conductor devices there is a continuing increase in device density and a concomitant decrease in device geometry. The present invention